Notice of Allowability	Application No.	Applicant(s)
	10/615,131	KAY ET AL.
	Examiner	Art Unit
	Hai C Pham	2861
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to <u>Application filed 07/08/03</u> .		
2. The allowed claim(s) is/are <u>1-13</u> .		
3. The drawings filed on <u>08 July 2003</u> are accepted by the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: Certified copies of the priority documents have been received. Certified copies of the priority documents have been received in Application No. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the 		
attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 07/08/03 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. ☐ Interview Summary Paper No./Mail Dat 08), 7. ☐ Examiner's Amendr	te

Application/Control Number: 10/615,131 Page 2

Art Unit: 2861

REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance: Claims 1, 5 1. and 9 are patentable over the prior art patents and printed publications because of the specific method and apparatus for aligning in five degrees of freedom a multichannel thermal laser printhead, which comprises providing a detection system having a narrow aperture and a photodetector, positioning the multichannel laser printhead in x and y directions parallel to the material transfer plane, scanning the narrow aperture for at least one channel of the multichannel laser printhead and at least one other channel from an out-of-focus position through an above focus position so that the controller receives the signals from the photodetector and the motion control system to produce the first and second series of laser irradiance profiles, determining correction values for roll and yaw of the multichannel laser printhead and distance of the multichannel laser printhead from the material transfer plane based on the produced laser irradiance profiles, aligning the multichannel laser printhead in accordance with the correction values, and establishing the x and y coordinates of each channel of the multichannel laser printhead with respect to x and y coordinates of the motion control system. The combined limitations are not taught by the art of record alone or in combination.

Claims 2-4, 6-8 and 10-13 are allowed because they are directly or indirectly dependent from claims 1, 5 and 9 above.

The prior art made of record, Tanimoto (U.S. 4,629,313), discloses an exposure apparatus for optically transferring a pattern on a semiconductor wafer provided with a

positioning control mechanism, a photosensor and slit openings, wherein the light intensity distributions of an out-of-focus condition and that of an in-of-focus condition are used for alignment purposes. However, the disclosed alignment configuration used for correcting a registration error due mainly to the distortion aberration of the projection optical system and thus fails to correct a positional relation between the light source and the semiconductor wafer.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hai C Pham whose telephone number is (571) 272-2260. The examiner can normally be reached on M-F 8:30AM - 5:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen D Meier can be reached on (571) 272-2149. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 10/615,131 Page 4

Art Unit: 2861

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

HAI PHAM
PRIMARY EXAMINER

HaichiPham

August 20, 2004